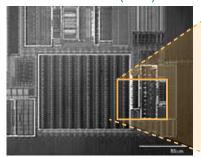
## **SEMICAPS PEM**

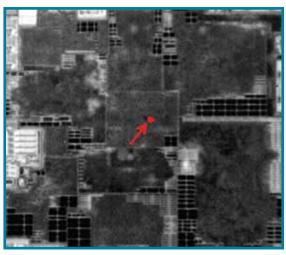
## PHOTON EMISSION MICROSCOPY

## Backside Emission of a 28 nm GPU device (50 X)







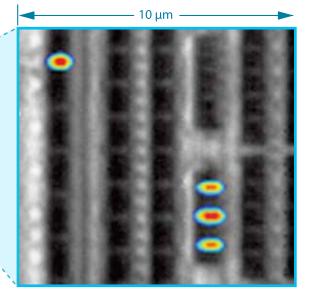


Backside Emission of Macro Lens Image: Courtesy of Globalfoundries (S)\*

## **Features**

- Multi Detectors (InGaAs, Extended InGaAs Cooled-CCD), various array sizes (1k x 1k, 640 x 512, 320 x 256) with cooling options - low noise LN2 or TE cooled (Peltier)
- Emissions Spectrum coverage from visible light to 2100 nm
- Dedicated macro lens for high emission sensitivity
- Modular platform field upgradeable to SOM and LTP
- Flexible and customizable
- Refractive Solid Immersion lens (RSIL) options

\*Microelectronics Reliability Vol 73. June 2017. Pages 76-91





SEMICAPS 1100



SEMICAPS 3000

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